9	œ	7	6	5	4	З	2		
BRS	BRS	BRS	BRS	BRS	BRS	IS&R	IS&R	BRS	Туре
798033	451	2944	110843	6054361	397327		28		Hits
alpha or amorphous	(tft or thin adj film) and (metal or aluminum or al!) near8 (substrate or wafer or alumina or sapphire or saphire) same (ono or oxynitride)	(tft or thin adj film) and (metal or aluminum or al!) same (ono or oxynitride )	ono or oxynitride	metal or aluminum or al!	tft or thin adj film	(("20020145683") or ("6,452,241") or ("6,327,006") or ("6,236,063") or ("20010000676") or ("6,172,721") or ("5,917,225") or ("5,771,110") or ("4,822,751")).PN.	(("20020145683") or ("6,452,241") or ("6,327,006") or ("6,236,063") or ("20010000676") or ("6,172,721") or ("5,917,225") or ("5,771,110") or ("4,822,751")).PN.	6621103.pn.	Search Text
USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT	DBs

16		15	14	သ	12	<u> </u>	10	
							<u></u>	
) ) ) ) ) ) )	BRS	BRS	BRS	BRS	BRS	BRS	BRS	Туре
	336433	1371875	69	94	43221	21486	711803	Hits
(metal or aluminum or al!) near8 (sio?	si?n? or "si.sub.3 or n.sub.4" or nitride	sub.2" or oxide	(((tft or thin adj film) and (metal or aluminum or al!) near8 (substrate or wafer or alumina or sapphire or saphire) same (ono or oxynitride )) and ((alpha or amorphous) same laser) and (pixel same driv\$4)) and (@ad <	((tft or thin adj film) and (metal or aluminum or al!) near8 (substrate or wafer or alumina or sapphire or saphire) same (ono or oxynitride )) and ((alpha or amorphous) same laser) and (pixel same driv\$4)	pixel same driv\$4	(alpha or amorphous) same laser	laser	Search Text
USPAT; US-PGPUB; EPO;	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	DBs

25	24	23	22	21	20	19	18	
BRS	Туре							
21486	711803	798033	21486	43221	397327	21486	153	Hits
(alpha or amorphous) same laser	laser	alpha or amorphous	(alpha or amorphous) same laser	pixel same driv\$4	tft or thin adj film	(alpha or amorphous) same laser	((metal or aluminum or al!) near8 (sio? or "sio.sub.2" or oxide) near8 (si?n? or "si.sub.3 or n.sub.4" or nitride)) and ((alpha or amorphous) same laser) and (pixel same driv\$4) and (@ad < "20020328")	Search Text
USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	DBs							

39	38	37	36	35	34	
BRS		BRS	BRS	BRS	BRS	Туре
232	886	1452	6057142	6057142	1468	Hits
(buffer near4 (sio? or "sio.sub.2" or oxide ) near4 (si?n? or "si.sub.3 or USPAT; Uspat; usub.4" or nitride )) and ((alpha or JPO; DEF amorphous) same laser ) and (tft or thin IBM_TDB adj film )	buffer near4 (sio? or "sio.sub.2" or oxide ) near4 (si?n? or "si.sub.3 or n.sub.4" or nitride )	(((sio? or "sio.sub.2" or oxide ) near8 (layer or conformal)) same ((si?n? or "Si.sub.3 or n.sub.4" or nitride ) near8 "JPO; DEF (layer or conformal)) and ((alpha or amorphous) same laser ) and (tft or thin adj film )) and (metal or aluminum or all	6057142 metal or aluminum or al!	6057142 metal or aluminum or al!	((sio? or "sio.sub.2" or oxide ) near8 (layer or conformal)) same ((si?n? or "Si.sub.3 or n.sub.4" or nitride ) near8 JPO; DEF (layer or conformal)) and ((alpha or amorphous) same laser ) and (tft or thin adj film )	Search Text
USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	DBs

51	50	49	48	47	46	
IS&R	BRS	BRS	BRS	BRS	BRS	Type
2260	ယ	5111	19	21	0	Hits
((438/149) or (438/151) or (438/486) or (438/487)).CCLS.	(substrate near4 electrode near4 capacitor) same (sio? or "sio.sub.2" or oxide ) near8 (si?n? or "si.sub.3 or n.sub.4" or nitride ) and (tft or thin adj film ) and ((alpha or amorphous) same laser)	substrate near4 electrode near4 capacitor	((black adj matrix) same (sio? or "sio.sub.2" or oxide ) same (si?n? or "si.sub.3 or n.sub.4" or nitride ) and (fft or thin adj film ) and ((alpha or amorphous) same laser )) and (@ad < "20020328")	(black adj matrix) same (sio? or "sio.sub.2" or oxide ) same (si?n? or "si.sub.3 or n.sub.4" or nitride ) and (tft or thin adj film ) and ((alpha or amorphous) same laser)	(black adj matrix) same (sio? or "sio.sub.2" or oxide ) same (si?n? or "si.sub.3 or n.sub.4" or nitride ) same (fft or thin adj film ) same ((alpha or amorphous) same laser)	Search Text
USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	DBs